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Substitute for form 1449A/PTO

## Itute for form 1449A/PTO STATEMENT BY APPLICANT

ATTORNEY'S DKT NO. 015290-592 10/075,602 **APPLICANT** Jeffrey HUNG et al. FILING DATE GROUP February 15 1765

			U.S. PATENT DOCUMENTS				
	U.S. Patent [			_			
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	<b>EP</b> 0407169		Europe	,	01-09-1991		
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. SEND TO: Assistant Commissioner for Patents, Washington, D.C. 20231. 1 2 2002

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## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

ATTORNEY'S DKT NO.	APPLICATION NO.
015290-592	10/075,602
APPLICANT	
Jeffrey HUNG et al.	
FILING DATE	GROUP
February 15, 2002	1765

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Examiner Initials	Include name of author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.						
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Examiner Signature	Lynette T. Umez-Ewnine Date Considered 6/14/2002						

